

**Search Notes**

Application/Control No.

10/614,701

Examiner

LOHA BEN

Applicant(s)/Patent under  
Reexamination

KIM ET AL

Art Unit

2873

**SEARCHED**

Class	Subclass	Date	Examiner
359	813	4/30/2005	LB
	814		
	823		
	824		
369	44.14		
	44.15		
	44.16		
	244		

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR